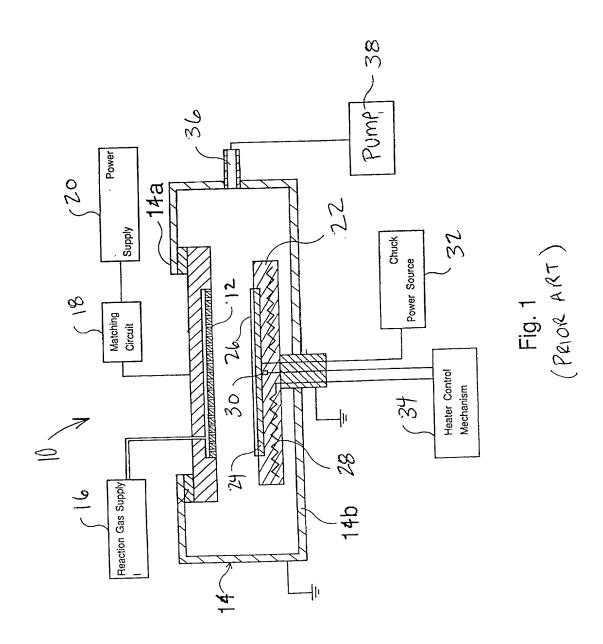
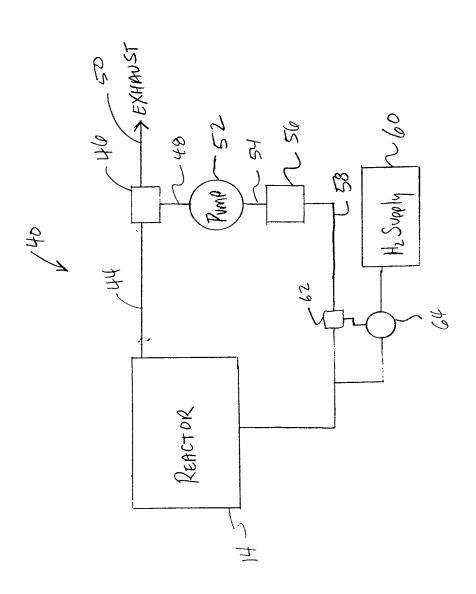
114



...

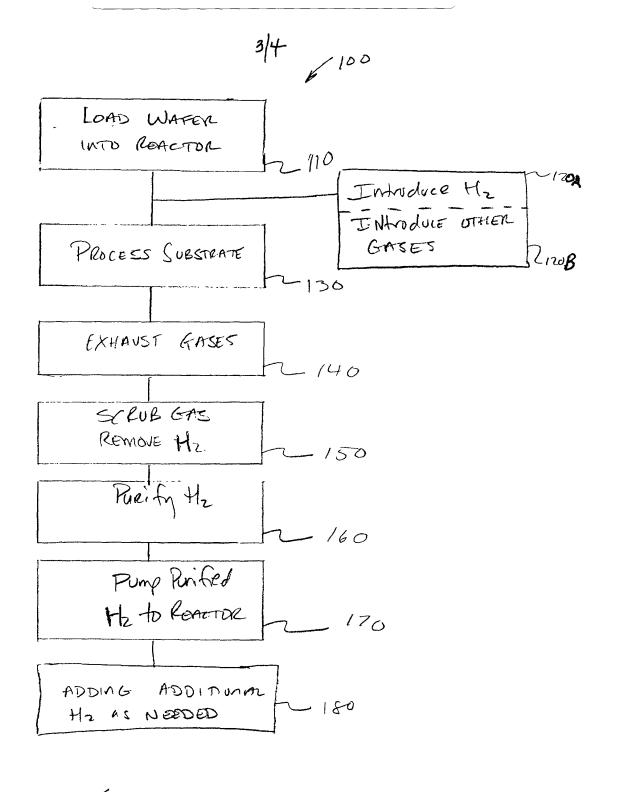
Complete the first and the fir

214

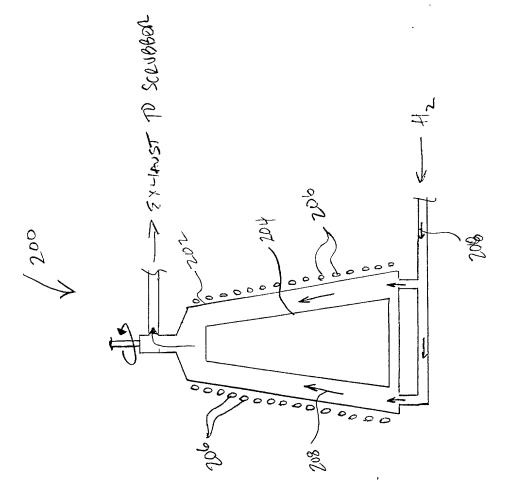


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METHOD FOR H₂ RECYCLING IN SEMICONDUCTOR PROCESSING SYSTEM YOO DOCKET NO. M-8608 US



F19-3



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